



46379

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Takashi FUJII et al. :  
Serial No.: 10/784,211 :  
Filed: February 24, 2004 :  
For: PROCESS FOR PRODUCING COLD :  
FIELD-EMISSION CATHODES :

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. § 1.97 and § 1.98, Applicants bring the disclosures attached and listed on completed Form PTO-1449 to the Examiner's attention and request that they be considered and made of record in this application.

Prompt examination on the merits is respectfully requested.

Respectfully submitted,

Garrett V. Davis  
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Dated: May 20, 2004

